



P/1071-1603

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Takeshi INAO

Serial No.: 10/674,451

Filed: September 30, 2003

For: POLISHING METHOD AND POLISHING APPARATUS USED FOR THE SAME

Confirmation No. 4123

Date: May 23, 2005

Group Art Unit: 3723

Examiner: Maurina T. Rachuba

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is a response to the Restriction Requirement mailed April 26, 2005 in the above-identified application. Reconsideration of the application is respectfully requested.

CONTINGENT EXTENSION REQUEST

If this communication is filed after the shortened statutory time period had elapsed and no separate Petition is enclosed, the Commissioner of Patents and Trademarks is petitioned, under 37 C.F.R. § 1.136(a), to extend the time for filing a response to the outstanding Office Action by the number of months which will avoid abandonment under 37 C.F.R. § 1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.